

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

JUNKO YOTANI, ET AL.

Application No.:

Filed:

For: **Method of Manufacturing
Electron-Emitting Source**

Art Group:

Examiner:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR PRIORITY

Sir:

Applicant respectfully requests a convention priority for the above-captioned application, namely:

| COUNTRY | APPLICATION NUMBER | DATE OF FILING |
|---------|--------------------|----------------|
| Japan | 110299/2003 | 15 April 2003 |

A certified copy of the document is being submitted herewith.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP



Eric S. Hyman, Reg. No. 30,139

Dated: 4/13/04

12400 Wilshire Boulevard, 7th Floor
Los Angeles, CA 90025
Telephone: (310) 207-3800